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PATENT

Entered

6-26-03
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Mueller

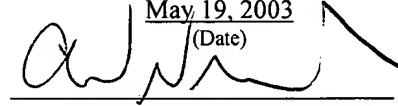


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : SOPHIE ET AL.
App. No. : 09/975,466
Filed : October 9, 2001
For : IN SITU REDUCTION OF COPPER
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CARBIDE DEPOSITION
Examiner : Kielin, E.

Group Art Unit 2813

I hereby certify that this correspondence and all
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Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on


May 19, 2003
(Date)
Andrew N. Merickel, Reg. No. 53,317

AMENDMENT AND REQUEST FOR RECONSIDERATION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present amendment is in response to the Final Office Action mailed on March 28, 2003, setting a three month term for response. As the present amendments are believed to place the application in condition for allowance, their entry is respectfully requested.